

Materials for Advanced Packaging

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Oak Ridge National Laboratory
National Transportation Research Center

**2017 U.S. DOE Vehicle Technologies
Office Annual Merit Review**

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Project ID: EDT079

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ORNL is managed by UT-Battelle
for the US Department of Energy



Overview

Timeline

- Start – FY16
- End – FY18
- 50% complete

Budget

- Total project funding
DOE share – 100%
- Funding received in
FY16: \$57k
- Funding for FY17: \$171k

Any proposed future work is subject to change based on funding levels

Barriers

- Reduce cost of electric drive technology with 1.4 kW/kg, 4 kW/l, and 94% efficiency characteristics
- Reliability and lifetime of power electronic (PE) modules degrade rapidly with increased temperature
- Heat transfer in contemporary PE modules are often material-limiting

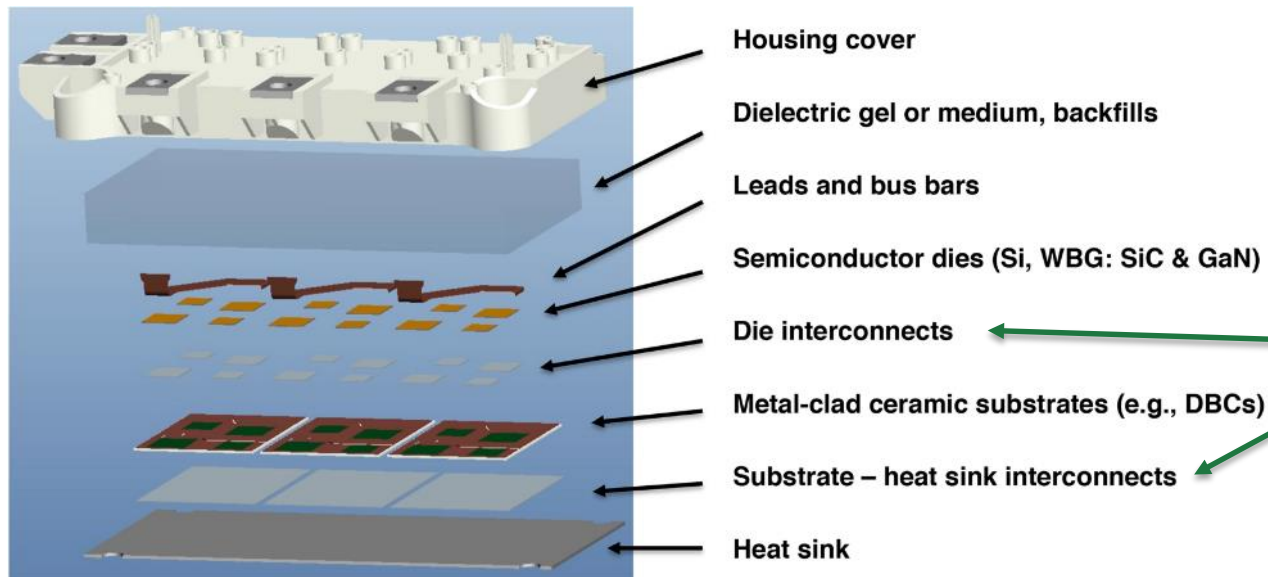
Partners

- Alfred University
- General Metal Finishing
- Henkel
- Heraeus
- Mount Union University
- NREL
- ORNL: Burress, Chen, Chinthavali, Modugno, Ozpineci, Wang, Waters, and Wiles
- Rogers Corporation
- UHV Sputtering

Project Objective and Relevance

- **Objective:** advance sintered-silver (Ag) interconnect technology to enable a 200°C-capable, low-cost, and reliable electronic package with at least 15-year-life
- **Relevance:** contemporary PE devices cannot operate at 200°C because most conventional interconnect materials (solders) are in non-equilibrium above 150°C

Example of a single-sided power electronic device



**Most solders
not 200°C-capable
(~ 150°C capable)**

Milestones

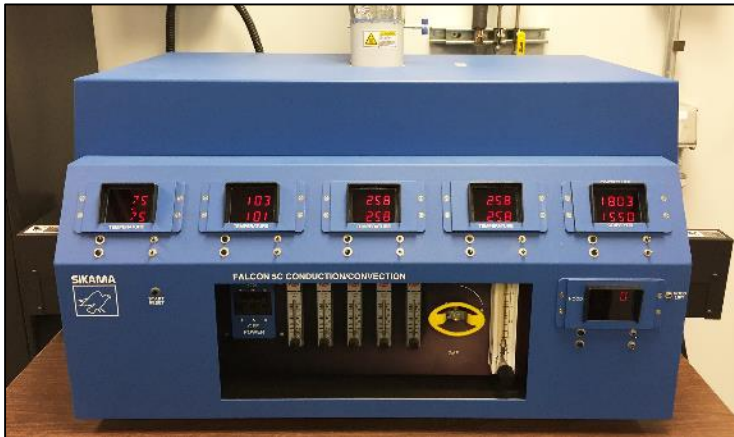
Date	Milestones and Go/No-Go Decisions	Status
2016	<u>Milestone:</u> Fabricate sufficient numbers of shear test specimens to judge potential of new contact-drying method for printed Ag paste	Completed
2016	<u>Go/No-Go decision:</u> Shear strength > 10 MPa achieved?	Go
Aug 2017	<u>Milestone:</u> Fabricate sufficient numbers of test specimens to judge shear strength of reflow-oven-processed sintered-Ag interconnects	On schedule
Aug 2017	<u>Go/No-Go decision:</u> Shear strength > 10 MPa achieved?	On schedule

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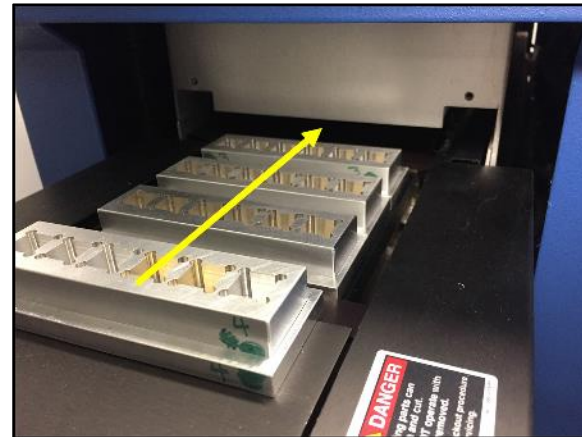
Approach/Strategy

- Advance the processing and mechanical reliability of sintered-Ag for power electronic devices
- Promote 200°C device operation
- Promote the use of common reflow oven technology for pressureless Ag-sintering of interconnects

ORNL Reflow Oven Used for Ag-Sintering Trials

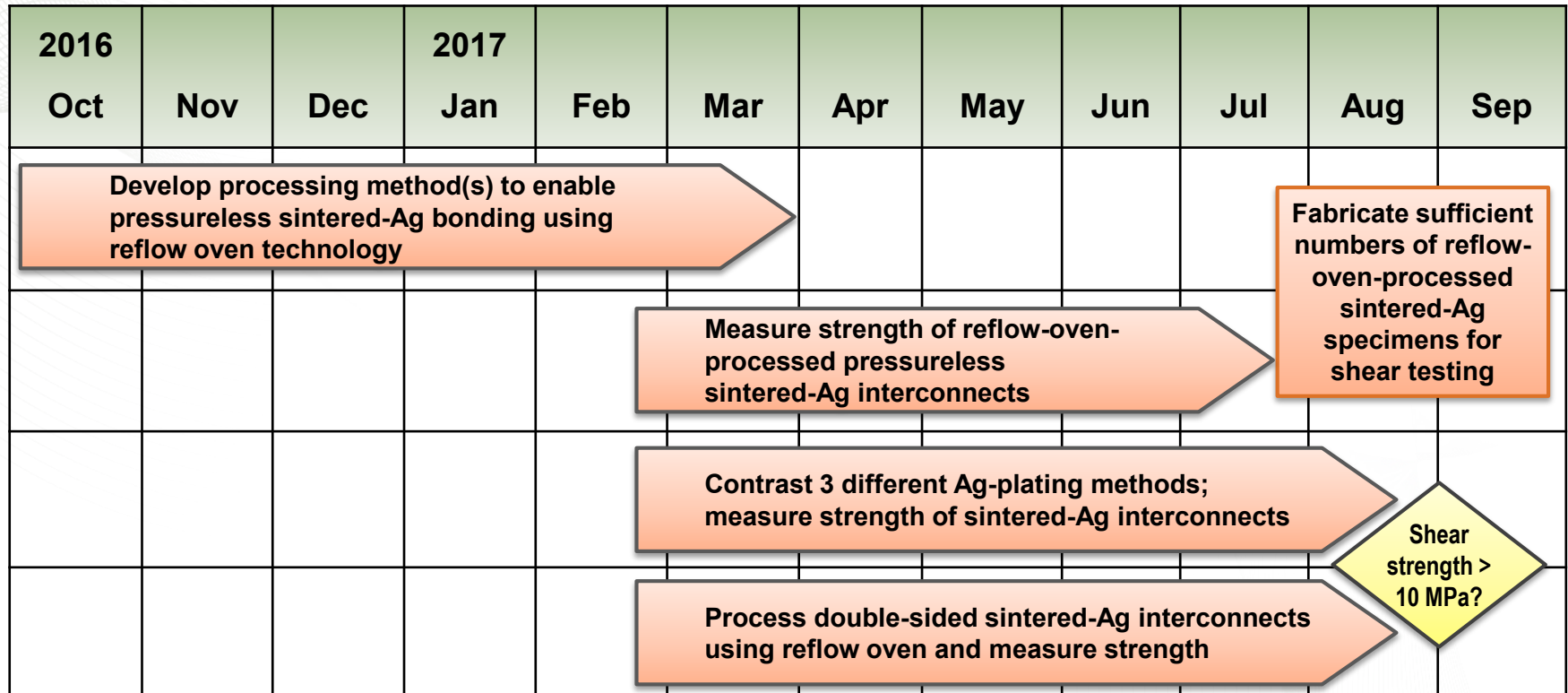


Sintered-Ag Specimens Going into Reflow Oven



Any proposed future work is subject to change based on funding levels

Approach FY17 Timeline



Go No/Go Decision Point: Demonstrate shear strength > 10 MPa for reflow-oven-processed, pressureless sintered-Ag interconnects. (31 August 2017)

Key Deliverable: Fabricate sufficient numbers of reflow-oven-processed sintered-Ag specimens for shear testing. (31 August 2017)

Any proposed future work is subject to change based on funding levels

Technical Accomplishments: Overview

1. Contact drying of printed sinterable-Ag paste
 2. Tension/shear via cantilever loading
 3. Apparent fracture toughness
- } New Test Methods

Disseminate results & interpretations to open literature

Contact Drying of Printed Sinterable-Silver Paste^a

Andrew A. Wereszczak,^b Senior Member IEEE, Max C. Modugno,^c
Brannndon R. Chen,^d and William M. Carty^e

*IEEE Transactions on Components, Packaging
and Manufacturing Technology*

Accepted

Apparent Fracture Toughness of Pressureless Sintered Silver Interconnects

Andrew A. Wereszczak, Senior Member, IEEE, Max C. Modugno, and Brannndon R. Chen

In Review

Failure Response of Sintered-Silver Interconnects via Cantilever Testing

Andrew A. Wereszczak, Senior Member, IEEE, Brannndon R. Chen, Osama M. Jadaan,
Max C. Modugno, Jeffrey W. Sharp, and James R. Salvador

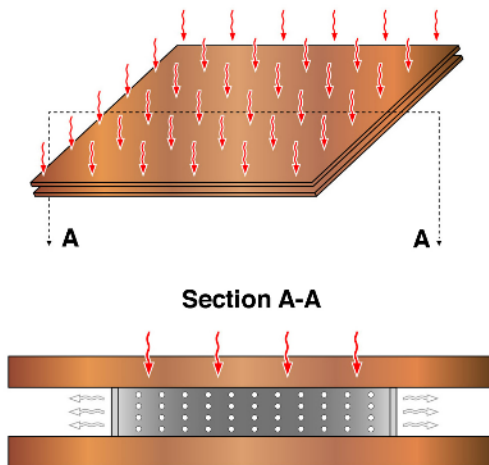
In Review

Technical Accomplishments: FY16-17 (1 of 6)

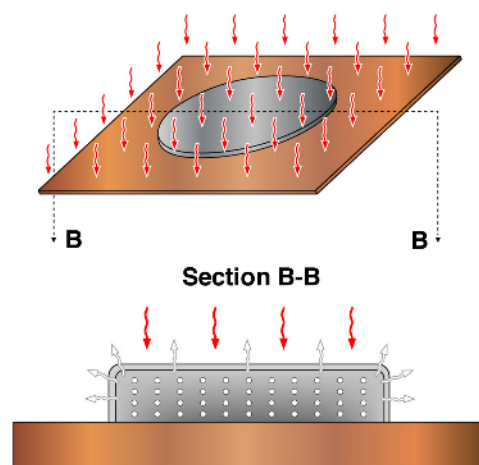
Contact Drying of Printed Sinterable-Ag Paste: Background

- Drying of printed sinterable-Ag paste is a crucial pre-sintering step yet taken-for-granted and overlooked
- Vendor-advocated convective drying methods are limiting
- Contact-drying is an enabler
- Conceived from previous research

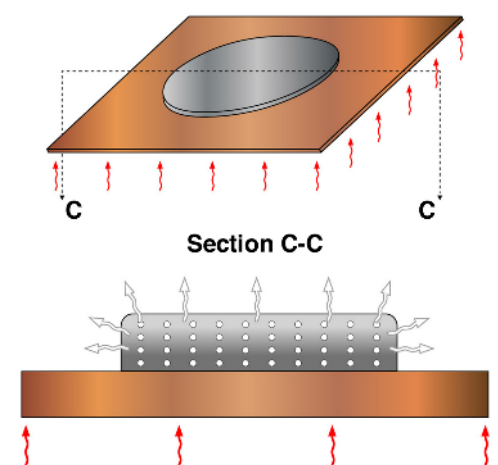
Closed Convective-Drying (Presently Used)



Open Convective-Drying (Presently Used)



Open Contact-Drying (ORNL Advocated)

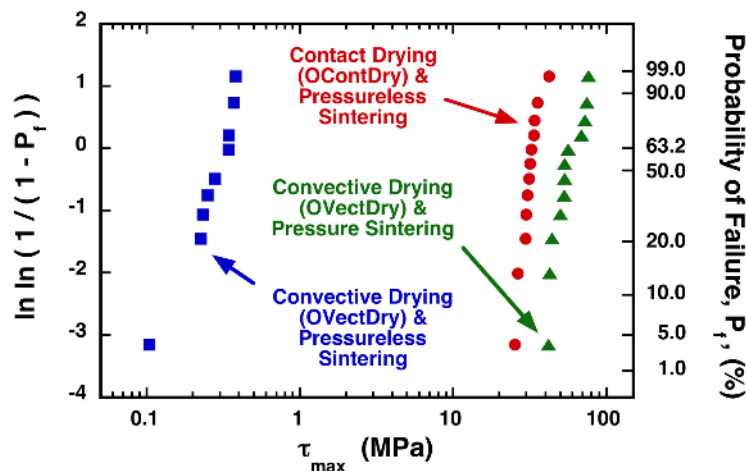


Technical Accomplishments: FY16-17 (2 of 6)

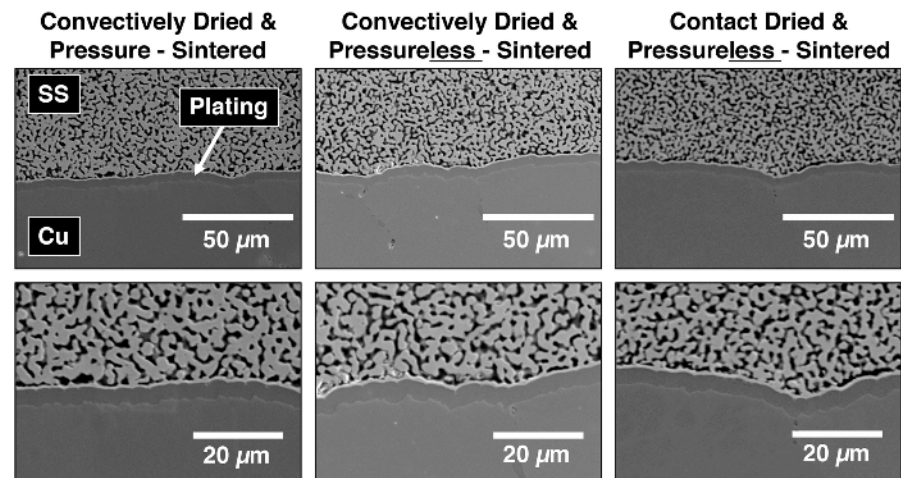
Contact Drying of Printed Sinterable-Ag Paste: Conclusions

- Contact drying enables the use of pressureless sintering, large area bonding, and reflow-oven processing
- Contact drying with pressureless sintered-Ag can produce good shear strengths and equivalent microstructures to those of pressure-assisted sintering

Good Strength



Equivalent Microstructures

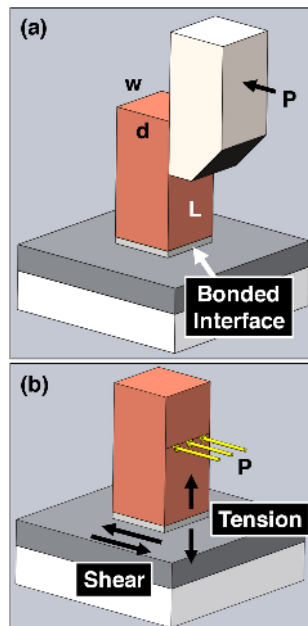


Technical Accomplishments: FY16-17 (3 of 6)

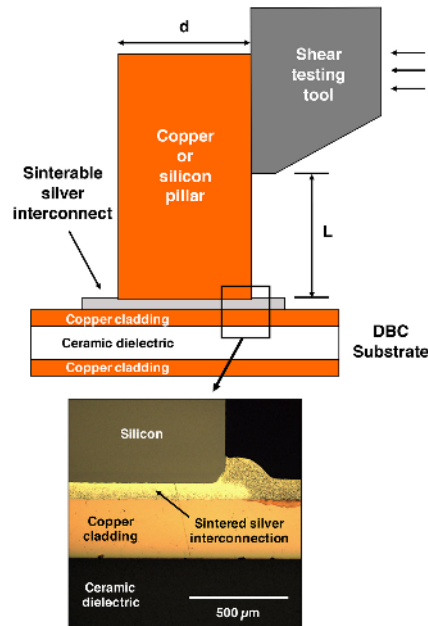
Tension/Shear Failure In Interconnects via Cantilever Loading: Background

- Cantilever testing benefits the understanding of how interconnects (e.g., sintered-Ag) mechanically respond
- Superimposes tension (primary) and shear
- Deep beam theory needed for correcting analysis

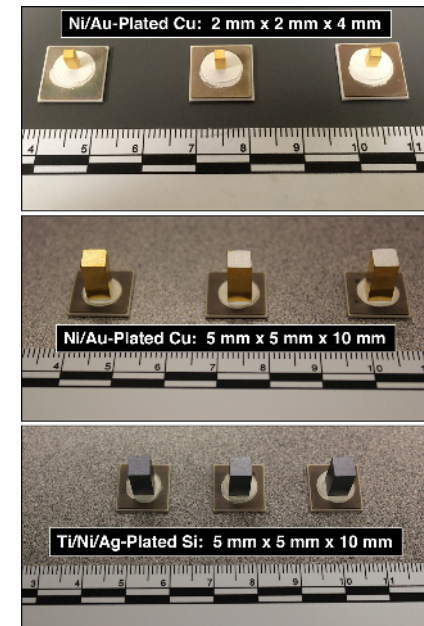
Loading Schematic



Interconnect Loading



Test Specimens

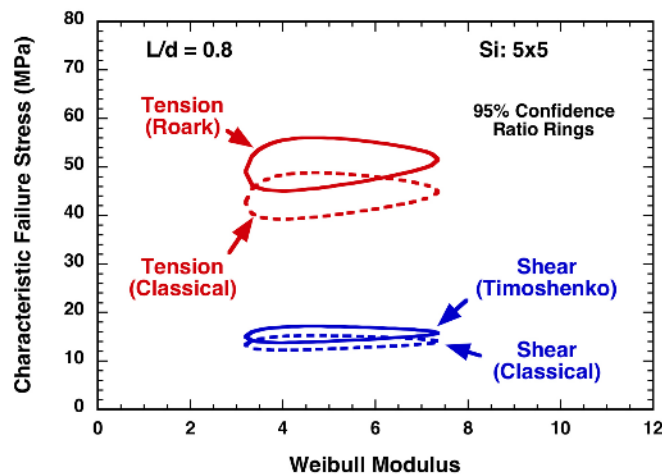


Technical Accomplishments: FY16-17 (4 of 6)

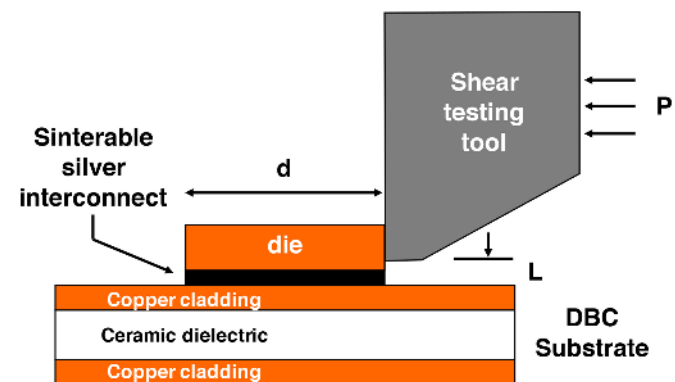
Tension/Shear Failure In Interconnects via Cantilever Loading: Conclusions

- **Ti/Ni/Ag plating on silicon, bonded to sintered-Ag, resulted in very strong interconnects**
- **Cantilever testing enables effective mechanical evaluation of interconnects (solders, sintered-Ag, etc.)**

Corrected Results from Deep Beam Theory



Die Test Applicability

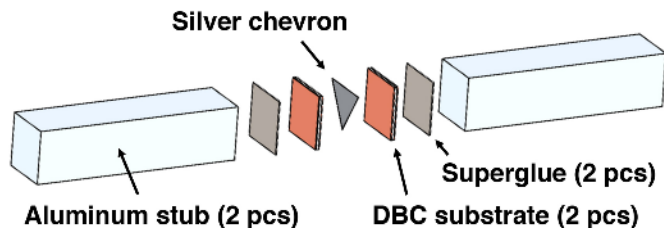


Technical Accomplishments: FY17 (5 of 6)

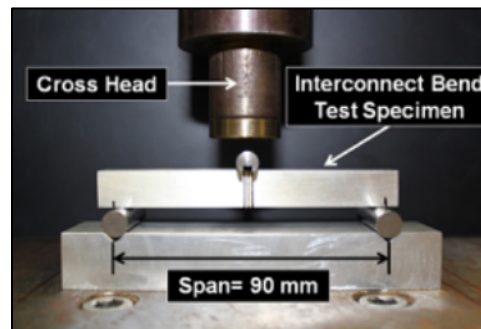
Apparent Fracture Toughness of Interconnects: Background

- **Susceptibility to crack growth or delamination in interconnects is related to fracture toughness (K_{Ic})**
- **Interconnect testing adapted from ASTM K_{Ic} test methods**
- **K_{Ic} is a useful complement to interconnect shear strength, tensile strength, and is associate with fatigue response**

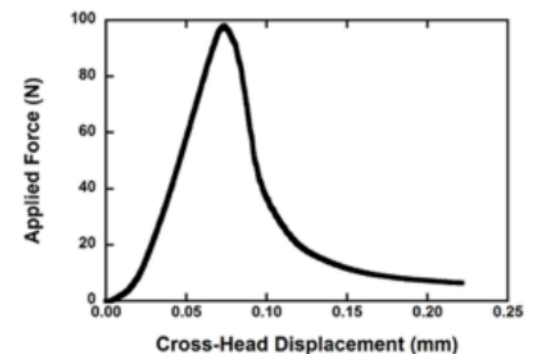
Schematic of Interconnect Bend Test Specimen (IBTS)



3-Point Bending of IBTS



Integrated Area Related to K_{Ic}



Technical Accomplishments: FY17 (6 of 6)

Apparent Fracture Toughness of Interconnects: Conclusions

- **The Ag-plating/sintered-Ag combo needs improvement**
- **K_{Ic} (interconnect sintered-Ag) < K_{Ic} (bulk sintered-Ag)**
- **Apparent first documentation of K_{Ic} of sintered-Ag**

Apparent Fracture Toughness (K_{Ic}) Comparisons

Interconnect Material	Apparent Fracture Toughness (MPa \sqrt{m})
Bulk Sintered Silver (this work)	2.3 - 2.4
Sintered-Silver Interconnect with Electroless Ag Plating (this work)	1.5 \pm 0.2
Various Solders (work of others)	1 - 11

Responses to Previous Year Reviewers' Comments

Project started after 2016 Annual Merit Review

Collaboration and Coordination with Other Institutions

Alfred University

- ***Alfred University:*** Alternative sinterable-Ag processing



- ***Mount Union University:*** Mechanical test development for interconnects



- ***National Renewable Energy Laboratory (NREL):*** Materials for electric motors (Bennion and Cousineau)



- ***General Metal Finishing:*** Metal plater



- ***Henkel:*** Sinterable-Ag manufacturer

- ***Heraeus:*** Sinterable-Ag manufacturer



- ***Rogers Corporation:*** DBC substrate manufacturer and plating studies



- ***UHV Sputtering:*** Metal plater

Remaining Challenges and Barriers

- **Identifying the most practical, reliable, and economical Ag (or other metal) plating choice for use with sintered-Ag interconnects**
- **Identifying conditions to avoid onset of delamination**

Any proposed future work is subject to change based on funding levels

Proposed Future Work

- **Remainder of FY17**
 - Reflow oven processing of sintered-Ag
 - Ag-plating study
 - Double-sided sintered-Ag study
- **FY18**
 - Process thick films directly on heat exchangers
 - Process sintered-Ag with thick film technology

Any proposed future work is subject to change based on funding levels

Summary

- **Relevance:**
 - Higher-temperature-capable materials, improved thermal transfer, reliability, and efficiency
 - Addresses major materials needs for the EV/HEV sectors
- **Approach/Strategy:** 200C - capable interconnects
- **Collaborations:** Industry, university, and national laboratory
- **Accomplishments:**
 - Measured thermal conductivity anisotropy in copper windings
 - Developed contact drying method with sintered-Ag
 - Identified, tensile, shear, and fracture toughness responses of sintered-Ag interconnects
- **Future Work:**
 - Complete reflow oven, Ag-plating, and double-sided sintered-Ag processing studies
 - Combine thick-film and sintered-Ag technologies

Any proposed future work is subject to change based on funding levels